



IFW

In re the application of:

Wen-Jian LIN

Group Art Unit: **2873**

Serial No: **10/807,129**

Examiner: **E.A. Lester**

Filed : **March 24, 2004**

For : **INTERFERENCE DISPLAY CELL AND FABRICATION
METHOD THEREOF**

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated August 22, 2005, applicant requests that the above-identified application be amended as follows: